

Notice of References Cited	Application/Control No. 10/050,207	Applicant(s)/Patent Under Reexamination BERNSTEIN ET AL.	
	Examiner Yubin Hung	Art Unit 2625	Page 1 of 1

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*	C	US-5,668,898	09-1997	Tatsuta, Seiji	382/290
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*	E	US-6,023,534	02-2000	Handley, John C.	382/275
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NON-PATENT DOCUMENTS

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	V	Morris et al., "A Sampling Based Approach to Line Scratch Removal from Motion Picture Frames," Proc. Of the Int'l Conf. on Image Processing, Vol. 1, 16-19 Sep. 1996, pp. 801-804
	W	Joyeux et al., "Film Line Scratch Removal Using Kalman Filtering and Bayesian Restoration," 5th IEEE Workshop on Applications of Computer Vision, 4-6 Dec. 2000, pp. 8-13
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.